

CV

Docket No. F-9089

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Joachim MAI, et al.  
Serial No. : 10/578,047  
Filed : August 7, 2007  
For : METHOD AND DEVICE FOR ION BEAM  
PROCESSING OF SURFACES  
Group Art Unit : 1795  
Examiner : Rodney Glenn McDonald  
Confirmation No. : 5426  
Customer No. : 000028107

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C. Bruce Hamburg  
(Name)

  
(Signature)

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

## AMENDMENT

Sir:

In response to the Office Action of September 8, 2010 please amend the above-identified patent application as follows: